

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 8585

Takashi OHSAKO et al.

Attorney Docket No. 2003 1364A

Serial No. 10/677,221

Group Art Unit 2823

Filed October 3, 2003

Examiner Joannie Garcia

METHOD OF MANUFACTURING SEMICONDUCTOR ELEMENT

Mail Stop: Amendment

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated March 4, 2008, a Petition for a one-month extension of time being submitted herewith, please amend the above-identified application as follows.

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975